

Customer No.: 31561
Application No.: 10/604,392
Docket NO.: 10606-US-PA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: LUND, JEFFRIE ROBERT

Group Art Unit: 1763

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In re PATENT APPLICATION of
Applicants : Chung-Yen Chou et al.

Serial No. : 10/604,392

Filed : July 17, 2003

For : GAS DISTRIBUTING SYSTEM
FOR DELIVERING PLASMA
GAS TO A WAFER REACTION
CHAMBER

AMENDMENT

) Attorney Docket: 10606-US-PA
) _____

No fee is believed to be due. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 10606-US-PA)

RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office
Customer Service Window
Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir,

The Office Action mailed on May 04, 2005 (Paper No. 20050429) has been carefully considered.

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